

PATENT APPLICATION - CERTIFICATE OF MAILING

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Specification and Claims (25 pages)
Drawings (8 pages)
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SEMICONDUCTOR MEMORY WITH EMBEDDED DRAM

PRIORITY CLAIM

[1] This application claims priority from Italian patent application
5 No. MI2002A002464, filed November 20, 2002, which is incorporated herein by
reference.

TECHNICAL FIELD

[2] The present invention generally relates to the field of semiconductor
10 memories.

BACKGROUND

[3] Semiconductor memories can be classified as volatile or non-volatile.

[4] The family of volatile memories includes for example Static RAMs (SRAMs),
15 Dynamic RAMs (DRAMs), and Pseudo-Static RAMs (PSRAMs). SRAMs are
capable of operating at very high speeds, but are relatively expensive and power
consuming; their main use is for fast-access, relatively small data storage areas
(such as, for example, cache memories for data processors). DRAMs are
significantly slower than SRAMs and require periodical data refreshes, but the
20 compactness of their elemental memory cells allows integrating very large arrays of
memory cells in a single semiconductor chip, and are therefore rather cheap;
DRAMs are mainly used as large data storage areas where very fast access is not
a primary goal. PSRAMs are substantially DRAMs with an embedded SRAM,
operating as a cache for the most recently accessed DRAM locations.

[5] The family of non-volatile memories includes mask ROMs, UV-erasable
25 Electrically Programmable ROMs (EPROMs) and Electrically Erasable and
Programmable ROMs, such as Flash memories and EEPROMs. In particular, Flash
memories have become rather popular thanks to the possibility they offer of altering
the data in a totally electrical way, and because large arrays of Flash memory cells
30 can be integrated in a single semiconductor chip. Flash memories are typically
exploited for storing data processor code and/or data.

[6] In several applications there is the necessity of providing both volatile and non-volatile memories: the former allow to easily read and write data, but do not preserve the stored data when the power supply is removed; the latter are slower, especially as far as writing of data is concerned, but guarantee that the stored data do not get lost.

[7] For example, when a Flash memory is provided to store a program for a microprocessor, it is preferable to have a volatile memory into which a piece of the program to be executed is stored; in this way, the fetching of the instructions by the microprocessor is faster, and data can be written in a time comparable with the read access time.

[8] Attempts have been made to integrate in a same chip both a Flash memory and a volatile memory. However, it is difficult to devise a manufacturing process optimised for both the type of memories, and the chip size significantly increases.

SUMMARY

[9] In view of the state of the art outlined above, an embodiment of the present invention provides a data storage semiconductor device or semiconductor memory in which a volatile memory is embedded, in particular a DRAM-like volatile memory, which was not affected by the problems discussed.

[10] In particular, the Applicant has found that components intrinsically and unavoidably present in a semiconductor memory, for example in a Flash memory, and normally considered as parasitic components, can be expediently exploited to build a DRAM-like volatile memory, without the need of changing the standard manufacturing process of the semiconductor memory in which the volatile memory is embedded, and with a very limited overhead in terms of semiconductor area.

[11] According to an aspect of the present invention, there is provided a semiconductor memory as set forth in appended claim 1.

[12] Briefly stated, the semiconductor memory comprises a plurality of memory cells, arranged in a plurality of lines, and a plurality of memory cell access signal lines, each one associated with at least one respective line of memory cells, for accessing the memory cells of the at least one respective line of memory cells.

[13] Each signal line has a capacitance intrinsically associated therewith, typically a parasitic capacitance.

[14] A plurality of volatile memory cells is also provided, each having a capacitive storage element. Each volatile memory cell is associated with a respective one of said signal lines, and the respective capacitive storage element is formed by the capacitance intrinsically associated with the respective signal line.

[15] The features and advantages of the present invention will be made apparent by the following detailed description of an embodiment thereof, provided merely by way of non-limitative example with reference to the annexed drawings, wherein:

[16] FIG. 1 schematically shows a memory according to an embodiment of the present invention, particularly a non-volatile memory and even more particularly a Flash memory, having a plurality of memory sectors;

[17] FIG. 2 schematically shows in greater detail a portion of the memory of FIG. 1;

[18] FIGS. 3A and 3B show in greater detail a column selection circuit arrangement for selecting columns of memory cells in a memory sector;

[19] FIGS. 4A and 4B schematically show some memory cells of a volatile memory embedded in the Flash memory, and a schematic of a circuit for selecting the volatile memory cells, according to an embodiment of the present invention;

[20] FIG. 5 schematically shows a circuit arrangement for reading and writing the volatile memory cells, according to an embodiment of the present invention;

[21] FIG. 6 schematically shows one embodiment of a circuit arrangement for the generation of reference signals for reading the volatile memory cells;

[22] FIG. 7 is a simplified timing diagram of a write operation conducted on the volatile memory; and

[23] FIG. 8 is a simplified time diagram of a read operation conducted on the volatile memory.

DETAILED DESCRIPTION

[24] The following discussion is presented to enable a person skilled in the art to make and use the invention. Various modifications to the embodiments will be readily apparent to those skilled in the art, and the generic principles herein may be applied to other embodiments and applications without departing from the spirit and scope of the present invention. Thus, the present invention is not intended to be limited to the embodiments shown, but is to be accorded the widest scope consistent with the principles and features disclosed herein.

[25] Referring to the drawings, a semiconductor memory according to an embodiment of the present invention is shown. In particular, the memory is a non-volatile memory and, even more particularly, a Flash memory, and comprises a matrix of Flash memory cells (hereinafter simply referred to as memory matrix), arranged by rows and columns.

[26] In a way known per-se in the art, Flash memory cells are formed of MOS transistors having a drain, a source, a control gate and a charge-storage element, for example a conductive, electrically-isolated floating gate or a charge-trapping dielectric layer, typically comprising silicon nitride or the like. The Flash memory cells may be intended to store one bit or more bits each.

[27] The Flash memory cells are grouped into a plurality of memory sectors. In particular, in the non-limitative example shown in the drawings, sixty-four memory sectors **S0 – S63** are provided, and the memory matrix layout is such as to define an upper half-matrix **HM1** and a lower half-matrix **HM2**; each half-matrix includes thirty-two memory sectors, respectively the memory sectors **S0 – S31** in the upper half-matrix **HM1**, and the memory sectors **S32 – S63** in the lower half-matrix **HM2**.

[28] In each half-matrix **HM1**, **HM2**, the respective memory sectors are arranged in rows and columns of memory sectors **S0-S63**, so as to define a two-dimensional array of memory sectors; in particular, in the shown embodiment, each row of memory sectors comprises eight memory sectors (e.g., the memory sectors **S0**, **S4**,..., **S28** in the first row of the upper half matrix **HM1**), and each column of memory sectors comprises four memory sectors (e.g., the memory sectors **S0 – S3** in the first column of the upper half matrix **HM1**).

[29] Typically, in a Flash memory the memory sectors **S0-S63** are the elemental memory blocks that can be individually erased electrically.

[30] Clearly, the layout of the memory matrix, the number of memory sectors, the size of the memory sectors **S0-S63**, depend on contingent circumstances, such as the memory size, the intended application and so on.

[31] Each memory sector **S0 – S63** comprises a two-dimensional array **201** of Flash memory cells **MC**, arranged by memory cell rows and memory cell columns (hereinafter shortly referred to as rows and columns). In particular, in an exemplary and non-limitative embodiment of the invention, each memory sector comprises 1024 rows and 1024 columns, for a total of 220 memory cells; the memory includes in this case 64 mega memory cells.

[32] Within each memory sector **S0-S63**, memory cells of a same column are connected to a same local bit line **LBL**, local to that memory sector. Each local bit line **LBL** of a memory sector is connectable to a respective global or main bit line **MBL**, which is common to all the memory sectors in a same column of memory sectors of the half-matrix (e.g., the first column of memory sectors **S0 – S3** in the upper half-matrix **HM1**). In particular, in an embodiment of the invention, each global bit line **MBL** is associated with a respective packet of local bit lines **LBL** in each memory sector **S0-S63** of the column of memory sectors. For example, as visible in **FIG. 2**, the packet of local bit lines includes four local bit lines **LBL1 – LBL4** in each memory sector **S0-S63** that are associated with a same global bit line **MBL1, MBL2,..., MBL256**; 256 global bit lines are thus provided for each column of memory sectors, both in the upper and in the lower half-matrices, for a total of 2048 global bit lines for the whole memory matrix.

[33] From a manufacturing viewpoint, the local bit lines **LBL** are for example defined in a first metal layer, and the global bit lines are defined in a second, upper metal layer, isolated from the first metal layer and contacting the latter in the desired points.

[34] As shown in **FIGS. 2, 3A and 3B**, each memory sector **S0 – S63** includes a local bit line selector **203**, allowing to selectively connect one of the four local bit

lines **LBL1 – LBL4** of each local bit line packet to the respective global bit line **MBL1, MBL2,..., MBL256**.

[35] A global bit line selector **205** is provided, that allows selecting the global bit lines **MBL**. The global bit line selector **205** connects the selected global bit lines to sensing circuitry and to programming circuitry, schematically shown as a single block **207**; conventionally, the sensing circuitry comprises sense amplifiers capable of sensing a current sunk by the memory cells, and the programming circuitry comprises program loads adapted to applying a programming voltage to the drains of the selected memory cells. In **FIG. 1**, a block **101** is intended to include the global bit line selectors **205**, the sensing circuitry and the programming circuitry.

[36] In each half matrix **HM1** and **HM2**, word lines **WL** are provided which are common to all the memory sectors **S0-S63** of a same row of memory sectors. Upper and lower word line selectors **103** and **105** allow selecting the word lines **WL** in the upper and, respectively, lower half-matrices.

[37] The local bit line selectors **203**, the global bit line selector **205** and the word line selectors **103** and **105** operate on the basis of address signals **ADD**; in particular, the local bit line selector **203** and the word line selector **103, 105** operate on the basis of a row address portion **RADD** of the address signals **ADD**, while the global bit line selector operates on the basis of a column address portion **CADD** of the address signals **ADD**. For any value of the address signals **ADD**, one of the memory sectors **S0 – S63** is selected and, within the selected memory sector, a group of memory cells forming a byte or a word are selected; such memory cells belong to a same word line (e.g., the word line **WLh** in **FIG. 3B**), and to different local bit lines **LBL**, belonging to local bit packets associated with different global bit lines **MBL**. The local bit lines **LBL** to which the selected memory cells belong are connected to the respective global bit lines **MBL** (e.g., the global bit lines **MBL1, MBL33,..., MBL225** in **FIG. 3B**); the local bit line selectors **203** in the remaining memory sectors **S0-S63** of the same memory sector column as the selected memory sector leave all the local bit lines **LBL** disconnected from the respective global bit lines **MBL**.

[38] In particular, as visible in **FIGS. 3A** and **3B**, the local bit line selector **203** comprises pass transistors driven by local bit line selection signals **YO1 – YO4**, generated by a decoder **301**, depicted as part of the word line selector **103**, receiving a first subset **RADD2** of the row addresses **RADD**; a second subset **RADD2** of the row addresses **RADD1** is instead fed to another decoder **303**, selecting the word lines **WL**.

[39] Also depicted in **FIGS. 3A** and **3B** is a hierarchical, two-level structure of the global bit line selector **205**. According to this two-level selection scheme, the global bit lines **MBL** in each column of memory sectors are grouped into groups each comprising a number of packets of, e.g., four global bit lines **MBL**. For example, if the memory has a byte-wide data word, eight groups of eight packets of global bit lines are provided. A first-level selector **305** allows selecting one global bit line **MBL** out of each packet of global bit lines. A second-level selector **307** allows selecting one among the eight packets of global bit lines in each group. The first- and the second-level selectors comprise pass transistors, driven by first-level and second-level selection signals **YN0 – YN4** and **YM0 – YM7**, respectively, generated by two decoders **309** and **311** each fed with a respective portion of the column addresses **CADD**. As many first- and second-level selectors **305** and **307** are provided as the degree of parallelism of the memory. For example, if the memory data word is byte-wide, eight first- and second-level selectors **305** and **307** are provided, allowing to simultaneously selecting eight Flash memory cells in a memory sector and making them accessible through memory data input/output terminals **I/O1 – I/O8**.

[40] In order to select a memory cell within, e.g., the memory sector **S3**, the word line **WL** to which the memory cell belongs is selected by means of the word line selector **303**, the local bit line to which the memory cell is connected is selected by means of the local bit line selector **203** and connected to the respective global bit line **MBL**; the global bit line to which the selected local bit line is associated is selected by the global bit line selector **205**. The drain electrode of the selected memory cell is thus coupled to the sensing circuitry, for reading the memory cell, or to the programming circuitry, for writing the memory cell.

[41] As schematically shown in **FIGS. 4A** and **4B**, each global bit line **MBL** has intrinsically associated therewith a parasitic capacitance; for example, referring to **FIG. 4A**, capacitors **CMBL1**, **CMBL4**, **CMBL29** and **CMBL32** represent, in terms of lumped circuit elements, the parasitic capacitances associated with the global bit lines **MBL1**, **MBL4**, **MBL29** and **MBL32**, respectively. The parasitic capacitance **MBL** associated with each global bit line **LBL** is the sum of several components, among which the junction capacitance of the transistors for the selection of the local bit lines associated with the global bit line, the capacitive coupling between the metal layer in which the global bit line is formed and the underlying/overlying layers of material, etc.

[42] According to an embodiment of the present invention, the parasitic capacitances **MBL** associated with the global bit lines **MBL** are exploited as capacitive data storage elements, and thus as volatile memory cells, so as to embed a volatile memory in the Flash memory. More specifically, according to an embodiment of the present invention, the parasitic capacitance associated with a generic global bit line is exploited to form the capacitor of a DRAM-like memory cell. For example, the parasitic capacitances **CMBL1**, **CMBL4**, **CMBL29** and **CMBL32** depicted in **FIG. 4A** form four DRAM-like memory cells that can be exploited to store data in addition to those stored in the Flash cells.

[43] Since the global bit line **MBL** decoding scheme is already designed to allow selecting specific global bit lines, according to the column addresses **CADD**, the DRAM-like memory cell associated with each global bit line can be selectively accessed through the same global bit line decoding scheme of the Flash memory. In particular, a generic one of the DRAM-like memory cells is accessed by selecting the global bit line **MBL** having associated therewith the parasitic capacitance forming the storage element of the DRAM-like memory cell. For example, the memory cell **CMBL1** is accessed by asserting the signals **YN0** and **YM0**, and keeping deasserted the other signals **YN1 – YN4** and **YM1 – YM7**. In this way, the global bit line **MBL1**, and thus the free plate of the capacitance **CMBL1**, can be connected to a circuit block **401**, intended to include a sense amplifier circuit adapted to sensing the DRAM-like memory cells, and a write circuit adapted to write the DRAM-like memory cells.

[44] A DRAM memory can thus be embedded in the Flash memory, exploiting elements already present in the integrated circuit, such as the parasitic capacitances *MBL* that are inherently associated with the global bit lines *MBL* and the global bit line selector **205**. This DRAM memory is thus in a sense "hidden" behind the Flash memory.

[45] It is observed that the embedded DRAM has the same degree of parallelism as the Flash memory. This means that if the Flash memory is designed to allow access to a byte or a word within the Flash memory, the same holds true for the embedded DRAM. This is schematically shown in **FIG. 4B**.

[46] In the embodiment discussed herein, a DRAM with 4096 memory cells is thus embedded in the Flash memory (256 DRAM cells for each column of memory sectors, 8 columns of memory sectors in each half-matrix).

[47] **FIG. 5** schematically shows an embodiment of the circuit block **401** in **FIGS. 4A** and **4B**.

[48] The DRAM cell write circuit comprises a voltage pull-up element and a voltage pull-down element, connected to the respective global bit line *MBL*; in particular, the voltage pull-up element comprises a P-channel MOSFET **P1**, and the voltage pull-down element comprises an N-channel MOSFET **N1**; the MOSFETs **P1** and **N1** are connected in series between a voltage supply line **VDD** (e.g., 5 V or 3 V) and a reference voltage line **GND** (the ground), and have drain electrodes connected to each other and to the respective global bit line *MBL*. A control circuit **501** controls the MOSFETs **P1** and **N1**. The control circuit **501** receives the datum to be written from a respective data input/output terminal *I/O* of the memory (any one of the eight terminals *I/O1* - *I/O8* of **FIGS. 4A** and **4B**). The MOSFETs **P1** and **N1** are normally kept off, so that the write circuit is kept in a high output impedance condition. During a write operation, the control circuit **501** turns on one of the two MOSFETs **P1** and **N1**, depending on the datum to be written into the DRAM memory cell: for example, if the datum to be written is a "0", the voltage pull-down MOSFET **N1** is turned on, so as to discharge to ground the capacitance **CMBL** of the global bit line *MBL*; on the contrary, if the datum to be written is a "1", the

voltage pull-up MOSFET **P1** is turned on, so as to charge the capacitance **CMBL** to the supply voltage **VDD**.

[49] The DRAM cell sensing circuit comprises a comparator **503**, with an input connectable, through the global bit line selector **205**, to a global bit line **MBL** specified by the column address portion **CADD**, and another input connected to a reference signal line **REF**. The comparator **503** feeds a latch **505** which is connected to the data input/output terminal **I/O** of the memory. The comparator **503** compares a signal that develops on the selected global bit line **MBL** with the reference signal, and provides an output logic state that is latched in the latch **505**.

10 [50] It is observed that the comparator **503** and the latch **505** can be part of the sensing circuitry already provided for reading the Flash memory cells, and can thus be shared, avoiding the need of providing dedicated circuits for the DRAM.

[51] FIG. 6 shows a circuit arrangement according to an embodiment of the present invention for the generation of the reference signal **REF** used for sensing the DRAM. Specifically, a structure of dummy global bit lines **DMBL** is exploited; for the purposes of the present description, by dummy there is intended not actively exploited for storing information. For reasons of electrical matching, the dummy structure is structurally identical to the global bit line **MBL** structure to which any global bit line belongs; as mentioned previously, in the embodiment of the invention discussed herein, any global bit line **MBL** belongs to a global bit line structure comprising eight packets of four global bit lines each; thus, the dummy structure identically comprises a group of thirty-two dummy global bit lines, subdivided in eight packets of four dummy global bit lines. Still for reasons of electrical matching, dummy local bit lines **DLBL** of dummy Flash memory cells, and dummy local bit line selectors are provided; in particular, one such structure of dummy elements may be provided in each of the columns of memory sectors in the upper and lower half-matrices. The structure of dummy elements also includes a dummy global bit line selector structure, comprising a dummy first-level selector and a dummy second-level selector. The dummy first-level and second-level selectors are such that one dummy global bit line is always selected, while the other dummy global bit lines are always kept deselected, and are present only for reasons of electrical

matching, for reproducing the effects that the unselected global bit lines have on the selected global bit line. The parasitic capacitance **CREF** associated with the selected dummy global line forms a reference DRAM-like cell.

[52] Associated with the dummy global bit line structure is a pre-charge circuit for pre-charging the reference DRAM cell to a state intermediate between the states corresponding to the logic states "1" and "0". In the shown example, the pre-charge circuit comprises a voltage partition network, comprising for example two resistors **R1**, **R2** connected in series between the supply voltage **VDD** and a the ground **GND**; a switch element, for example an N-channel MOSFET **N2**, is controlled by a pre-charge signal **PCH** and is turned on to enable the pre-charge of the DRAM reference cell to half the value of the supply voltage **VDD** ($VDD/2$). In particular, the pre-charge of the DRAM reference cell is performed before every read operation of the cells of the embedded DRAM. In this way, account is taken of the loss of charge due to the leakages. In case the datum stored in the DRAM cell to be sensed is a "0", the loss of charge reduces the difference in voltage between the DRAM cell to be sensed and the DRAM reference cell, since the voltage across the capacitor of the latter tends to fall from $VCC/2$. In case the datum to be sensed is a "1", it is reasonably expected that both the DRAM cell to be sensed and the DRAM reference cell will undergo a substantially identical loss of charge, due to the fact that the dummy structure is substantially identical to the matrix one.

[53] The operation of the memory will be now described making reference to the timing diagrams of **FIGS. 7** and **8**.

[54] It is observed that the Flash memory and the DRAM are to be operated in a mutually exclusive way. When the Flash memory is accessed, the parasitic capacitances of the global bit lines are charged/discharged/left undisturbed depending on the Flash memory cells to be accessed and the data stored therein; therefore, at least some of the data stored in the DRAM get lost in consequence of an access to the Flash memory.

[55] It is observed that this is not a major limitation: access to the Flash memory may take place from now and then, and the DRAM can be used as a temporary storage area of data in the time intervals between accesses to the Flash memory.

For example, the Flash memory can be accessed to retrieve a portion of the data stored therein, for example a portion of code to be executed by a microprocessor; the retrieved code portion can be stored into the DRAM, and the code instructions be then fetched from the DRAM, instead that from the Flash memory.

5 [56] Prior to accessing the DRAM for either writing or reading data, the access to the Flash memory cells is to be inhibited. This can for example be achieved simply by forcing all the local bit line selection signals **YO1 – YO4** of all the local bit line selectors **203** to a deasserted state, so that all the pass transistors of the local bit line selector are forced off. This ensures that the local bit lines **LBL**, and thus the
10 drains of the Flash memory cells connected thereto, are isolated from the global bit lines **LBL**.

[57] The operation of the hidden DRAM will be described referring first to a write operation, and then to a read operation.

15 Write operation

[58] Referring to **FIG. 4A**, let it be assumed that a datum is to be written into the DRAM cell having as storage element the capacitor **CMBL1**, i.e., the parasitic capacitance of the global bit line **MBL1**. Exploiting the column address signals and the global bit line selector **205** of the Flash memory, the global bit line **MBL1** is
20 selected. In the case herein discussed, the first-level selection signal **YN0** is asserted, while the remaining first-level selection signals **YN1 – YN3** are kept de-asserted, and the second-level selection signal **YM0** is asserted, while the remaining second-level selection signals **YM1 – YM7** are kept de-asserted.

[59] It is observed that in order to avoid any sharing of charge between the
25 parasitic capacitances associated with different global bit lines **MBL**, it is preferable that the assertion of the selection signals **YN0 and YM0**, leading to the selection of the desired global bit line **MBL1**, takes place only after all the other first and second level selection signals have been de-asserted, i.e., the selection signals **YN0** and **YM0** are asserted (**FIG. 7**, instant t1) starting from a condition in which all the first
30 and second level selection signals are in a de-asserted state.

[60] The writing circuit, initially kept in a high-impedance condition by the write

control circuit **501** (MOSFETs **P1** and **N1** off), is enabled (instant **t2**). One of the MOSFETs **P1** and **N1** is turned on by the write control circuit **501**, depending on the datum to be written, received at the data input/output terminal **I/O** of the memory. In particular, in order to write a "1", the voltage pull-up transistor **P1** is turned on (signal P-UP asserted low), and the voltage pull-down transistor **N1** is kept off (signal P-DW kept low): the capacitance **CMBL1** is thus charged to the voltage supply **VDD**; in order to write a "0", the voltage pull-up transistor **P1** is kept off, and the voltage pull-down transistor **N1** is turned on: the capacitance **CMBL1** is thus discharged to ground.

10 [61] After a time sufficient for the capacitance **CMBL1** to charge up to the supply voltage **VDD** or to discharge to ground, the first and second level selection signals **YN0** and **YM0** are de-asserted (instant **t3**), so that the global bit line **MBL1** is isolated, and then the writing circuit is returned to the high-impedance condition (instant **t4**).

15 [62] It is pointed out that all the operations previously described are carried out in parallel on all the DRAM cells making up the byte or word of the DRAM, which in the present embodiment has the same size as the data word of the Flash memory.

Read operation

20 [63] Let it be assumed again that the DRAM cell having the storage capacitor formed by the parasitic capacitance **CMBL1**, associated with the global bit line **MBL1**, is to be accessed, this time to read the datum stored therein.

[64] As in the case of the write operation, the global bit line **MBL1** is selected: the first-level decoding signal **YN0** is asserted, while the remaining first-level selection signals **YN1** – **YN3** are kept de-asserted, and the second-level selection signal **YM0** is asserted, while the remaining second-level selection signals **YM1** – **YM7** are kept de-asserted. Also in this case, in order to avoid any sharing of charge between the parasitic capacitances associated with different global bit lines **MBL**, it is preferable that the selection signals **YN0** and **YM0** are asserted (FIG. 8, instant **t1**) starting from a condition in which all the first and second level selection signals are de-asserted.

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[65] The charge stored in capacitance **CMBL1** is then sensed (instant **t2**). The selected global bit line **MBL1** is coupled to an input terminal of the comparator **503**, receiving at the other input terminal the reference signal **REF** generated in the present example by the structure depicted in **FIG. 6**; it is pointed out that the pre-charge operation of the reference cell precedes the read operation herein described. The sensing phase ends (instant **t3**) after a time sufficient for the output **SD** of the comparator **503** to settle. The sensed datum is thus available at the output of the comparator **503**.

[66] As in any DRAM, the read operation of a DRAM cell destroys the stored datum: charge sharing effects due to the inevitable presence of parasitic elements cause in fact the charge stored in the capacitance **CMBL1** to be lost during the read. It is thus necessary to write the datum back into the accessed DRAM cell. To this purpose, the datum, present at the output of the comparator **503**, is latched into the latch **505** upon assertion of the signal **LTC**, instant **t3**, and a write operation similar to the one described above is carried out. The latched datum is fed back to the write control circuit **501**; the writing circuit, so far kept disabled, is enabled, and the voltage pull-up and pull-down transistors **P1**, **N1** are turned on/off (signals **P-UP** and **P-DW** asserted or kept de-asserted, time interval **t4 – t6**) depending on the datum to be rewritten.

[67] Conventional DRAMs need to be periodically refreshed, so that the stored data are not lost due to current leakages.

[68] In the present case, it is observed that the parasitic capacitances **CMBL** exploited as DRAM storage capacitors are substantially heavier than the tiny capacitances normally used for fabricating large DRAM cell arrays. Parasitic capacitances of the order of 1 pF can be typical which, in view of the expected leakage currents, have relatively long discharge times (of the order of some milliseconds). Thus, data refresh schemes could be avoided.

[69] Data refreshing schemes can however be implemented in order to periodically refresh the data stored in the DRAM cells, thereby ensuring that the stored data are not lost due to leakages. In particular, the data refresh operation may be entrusted to the user of the memory, as in conventional DRAMs: the DRAM

is periodically accessed in reading, so that the stored information is automatically written back into the DRAM cells. Alternatively, internal self-refresh circuits can be provided in the memory, for autonomously conducting the data refresh of the DRAM.

5 [70] In the embodiment of the invention described herein, the parasitic capacitances **CMBL** associated with the global bit lines **MBL** are exploited to form capacitive data storage elements. It is however observed that not only the global bit lines **MBL**, but also the local bit lines **LBL** have parasitic capacitances intrinsically associated therewith. For example, in **FIG. 4A** the lumped circuit element **CLBL1**
 10 denotes the parasitic capacitance associated with the local bit line **LBL1** in the memory sector **S3**.

[71] The Applicant has observed that also the parasitic capacitances **CLBL** associated with the local bit lines **LBL** can be exploited as capacitive storage elements of DRAM-like memory cells, in the same way as the parasitic
 15 capacitances **CMBL** associated with the global bit lines **MBL** are exploited. In this case, in order to access a specific DRAM-like memory cell, it is also necessary to exploit the local bit line selectors **203**.

[72] Exploiting the parasitic capacitances **CLBL** inherently associated with the local bit lines **LBL**, instead of the parasitic capacitances **CMBL** associated with the
 20 global bit lines **MBL**, allows obtaining, without any overhead in semiconductor area, a DRAM-like memory that is, in the present example, four times larger than the DRAM-like memory that could be obtained using the parasitic capacitances associated with the global bit lines.

[73] However, the Applicant has observed that exploiting the parasitic
 25 capacitances **CLBL** associated with the local bit lines **LBL** does not allow leaving the Flash memory cells undisturbed when using the DRAM-like memory. In fact, as can be seen from **FIG. 4**, the charging/discharging of the capacitance **CLBL1** may cause an electrical stress on the Flash memory cells having drains connected to the local bit line **LBL1**.

30 [74] On the contrary, exploiting the parasitic capacitances **CMBL** associated with the global bit lines **MBL**, it is possible to operate on the DRAM-like memory without

disturbing the Flash memory; in fact, when operating on the DRAM-like memory, the local bit line selectors **203** can be kept disabled, so that the local bit lines **LBL** are disconnected from the respective global bit lines **MBL**.

5 [75] In any case, if one accepts to have the Flash memory cells slightly stressed during the operation of DRAM-like memory, the use of the parasitic capacitances **CLBL** associated with the local bit lines **LBL** allows obtaining a rather large DRAM-like memory.

10 [76] Concerning the size of the embedded DRAM, in the embodiment discussed herein, one DRAM cell is associated to each global bit line **MBL**; a DRAM with 4096 memory cells is thus embedded in the Flash memory (256 DRAM cells for each column of memory sectors, 8 columns of memory sectors in each half-matrix).

[77] Alternative embodiments allow increasing the size of the DRAM embedded in the Flash memory.

15 [78] For example, the global bit lines **MBL** may be segmented: each global bit line may be segmented in two or more global bit line segments. When the Flash memory needs to be accessed, the different segments of a same global bit line **MBL** are connected to each other to form a single global bit line; on the contrary, the different global bit line segments are kept separated from each other when the DRAM needs to be accessed. Switch elements, for example pass transistors, are
20 suitable for enabling this global bit line segmentation. In this way, exploiting the parasitic capacitance associated with each global bit line segment, the number of DRAM cells is increased. Clearly, in order to selectively access the different global bit line segments, the global bit line selector **205** needs to be expanded.

25 [79] Alternatively, the number of global bit lines **MBL** in the shown example, one every four local bit lines) can be doubled.

[80] In particular, the number of global bit lines **MBL** may be increased by providing dummy global bit lines **DMBL**, which are left floating when the Flash memory is accessed; it is observed that such dummy global bit lines might be expediently exploited also by the Flash memory, which could use them for
30 associating with the reference cells necessary for sensing the Flash memory cells the parasitic capacitances required for matching the Flash memory cells to be

sensed.

[81] The size of the DRAM may be further increased adopting a multi-level approach similar to that already adopted in some non-volatile memories, e.g. Flash memories. For example, the DRAM-like cell storage capacitors can be charged to
5 four distinct voltage levels, e.g. the ground, the supply voltage, and two further levels intermediate between the ground and the supply voltage. Assuming by way of example a supply voltage **VDD** of 3 V, the DRAM-like cell storage capacitor may be charged to 0 V, 1 V, 2 V and 3 V. In this way, each DRAM cell is capable of storing two bits, and the DRAM size is doubled. The multi-level approach is difficult
10 to be implemented in conventional DRAMs, wherein the storage capacitors are tiny and charge-sharing effects prevent from discriminating between slightly different charge voltages. In the present case the DRAM cell storage capacitor is instead relatively large and less affected by charge-sharing effects.

[82] In case the multi-level DRAM is embedded in a multi-level Flash memory,
15 the same sensing circuits provided for reading the multi-level Flash memory cells can be exploited for reading the multi-level DRAM cells.

[83] The embedded DRAM architecture can be advantageously exploited in dual-bank Flash memories: in this case, one Flash memory bank and the DRAM embedded in the other Flash memory bank can operate simultaneously. The
20 DRAM can be used as a memory buffer (for example, a write memory buffer storing data to be written into the other Flash memory bank), or as a shadow memory.

[84] The present invention has been herein described by way of some embodiments in connection with a Flash memory. Those skilled in the art will readily recognize that the invention can actually be applied to other types of
25 memories, either non-volatile or volatile. For example, exploiting the parasitic capacitance of the bit lines, the invention can be exploited in a DRAM, to create an embedded, secondary memory, or in a SRAM, in a mask ROM, in an EPROM, in an EEPROM. The invention can be applied in general whenever a matrix structure is present.

[85] The described embodiment of a Flash memory and other types of memory
30 including the described embodiments an embedded DRAM may be utilized in a

variety of different types of electronic systems, such as a computer system.